



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Elkind et al.

Docket No.: TI-30785

Serial No.: 10/053,454

Art Unit: 2851

Filed: 10/25/01

Examiner: Sever, Andrew T

Title: Robust Integrated Surface Plasmon Resonance Sensor

AMENDMENT UNDER 37 CFR 1.116

January 26, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)	
I hereby certify that the above correspondence is being deposited	
with the U.S. Postal Service on	
<u>1-26-04</u>	as First Class Mail in an
envelope addressed to: Commissioner for Patents, P.O. Box 1450,	
Alexandria, VA 22313-1450	
<u>Karen Vertz</u>	<u>1-26-04</u>
Karen Vertz	Date

In response to the Office Action, dated 11/13/2003, in the above-identified patent application, please make the following amendments. They are respectfully submitted as a full and complete response to that Action. Charge any required fees to the deposit account of Texas Instruments Incorporated, Account No. 20-0668.